

**Search Notes**

Application/Control No.

10/616,017

Examiner

Michael C. Wimer

Applicant(s)/Patent under  
Reexamination

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Art Unit

2828

**SEARCHED**

Class	Subclass	Date	Examiner
343	756,786	2/10/2005	MCW
333	21A, 126	2/10/2004	MCW
333	135,137	2/10/2005	MCW

**INTERFERENCE SEARCHED**

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343	756,786	2/14/2005	MCW
333	21A, 126	2/14/2005	MCW
333	135,137	2/14/2005	MCW

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR